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PRODUCT SPOTLIGHT



Fused Silica Scan Lenses

The S4LFT1655/328 is very suitable for stereolithography applications in the infrared wavelength range. The lens has a scan field of 410 mm x 410 mm which enables the production of very large components. With a free input beam diameter of 20 mm focus sizes in the range of 64 to 72 μm — depending on the scan field position — are achievable. The S4LFT1655/328 is a fused silica lens and it is suitable for high power laser applications. Check out our data sheet for more information.

Download the data sheet for more information.

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